	Application No.	Application No. Applicant(s)	
	10/724,513	COHEN ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Edna Wong	1795	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT I of the Office or upon petition by the applicant. See 37 CFR 1.31	pears on the cover sheet w S (OR REMAINS) CLOSED i S) or other appropriate comm RIGHTS. This application is	ith the correspondence address- n this application. If not included unication will be mailed in due cour	se. THIS
1. \boxtimes This communication is responsive to <u>Amendment After Fig.</u>	inal dated December 18, 200	<u>17</u> .	
2. The allowed claim(s) is/are 14-21.			•
 3. Acknowledgment is made of a claim for foreign priority of a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents 	ve been received. ve been received in Applicati	on No	from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which gives	MENT of this application. mitted. Note the attached EX	AMINER'S AMENDMENT or NOTIC	
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ust be submitted.		
(a) \square including changes required by the Notice of Draftsper	rson's Patent Drawing Revie	w (PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	 _•		
(b) ☐ including changes required by the attached Examine Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on t	he drawings in the front (not the bac	k) of
6. DEPOSIT OF and/or INFORMATION about the dep- attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MAT	ERIAL must be submitted. Note	the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5 \(\sum \) Notice of Ir	formal Patent Application	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	•	ummary (PTO-413),	
3. ☐ Information Disclosure Statements (PTO/SB/08),	Paper No.	/Mail Date Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material		Statement of Reasons for Allowan	ce
	9. ☐ Other	EDNA WONG PRIMARY FYAMINED	

REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

Claims **14-21** are allowable over the prior art of record because the prior art does not teach or suggest a process for forming a multilayer three-dimensional structure, comprising the steps of (a) forming and (b) repeating as presently claimed.

The prior art does not contain any language that teaches or suggests the above. JP 57-67193 teaches a mask for partial plating and a partial plating method. A mask for partial plating is composed of a rigid member 10 and an elastic mask member 12 adhered to the member 10. The tip of the bellows part 12B of the mask is pressed against a package 18 to be plated for a semiconductor device to seal the surfaces to be masked in the sealing space 19. In this state a face 22 to be plated is plated to perform perfect partial plating (abstract; and Fig. 2). JP 57-67193 does not teach the steps of (a) forming and (b) repeating as presently claimed and providing a desired electrolyte within the at least one electrochemical process pocket.

Therefore, a person skilled in the art would not have been motivated to adopt the above conditions, and a prima facie case of obviousness cannot be established.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number:

10/724,513

Art Unit: 1795

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Edna Wong whose telephone number is (571) 272-1349. The examiner can normally be reached on Mon-Fri 7:30 am to 4:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam Nguyen can be reached on (571) 272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Edna Wong
Primary Examiner

Art Unit 1795

EW

December 20, 2007